

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Sung-Hwa LEE et al.

Application No.: 10/539,552

Confirmation No.: 2680

Filed: June 16, 2005

Art Unit: 3742

For: COOLING STRUCTURE FOR PLASMA
LIGHTING SYSTEM

Examiner: Q. Van

STATEMENT OF THE SUBSTANCE OF THE INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

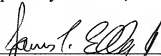
Applicants submit the following statement on the substance of the interview held on December 21, 2010.

Applicants' representative argued that Mimasu does not disclose a fan housing having at least one inlet port and at least two discharge ports having different flow rates for discharging introduced external air into the case with different flow rates from each other. The Examiner agreed to perform a further search and reconsider the arguments.

If necessary, the Director is hereby authorized in this, concurrent, and future replies to charge any fees required during the pendency of the above-identified application or credit any overpayment to Deposit Account No. 02-2448.

Dated: February 3, 2011

Respectfully submitted,

By 

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